



PATENT  
Attorney Docket No.: SAM-0396

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Kun-Hyung Lee, *et al.*  
Serial No.: 10/619,112  
Filing Date: July 14, 2003  
Title: APPARATUS AND METHOD FOR PROCESSING WAFERS

Examiner: Adams, Gregory W.  
Group Art Unit: 3652

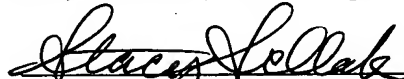
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Stacy Sedlak

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Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

AMENDMENT A

Sir:

The following is in response to the Office Action dated May 6, 2005, and is filed within the shortened statutory period of three months. Please amend the application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Amendments to the Drawings** begin on page 10 of this paper and include both an attached replacement sheet and an annotated sheet showing changes.

**Remarks/Arguments** begin on page 11 of this paper.

**An Appendix** including amended drawing figures is attached following page 13 of this paper.